

Multirate control for high accuracy and low cost: dual-stage experiments

Jurgen van Zundert^a

Tom Oomen^a
Wouter Aangenent^b
Maurice Heemels^a



^aControl Systems Technology group
^bASML Research Mechatronics & Control

Dual stage systems

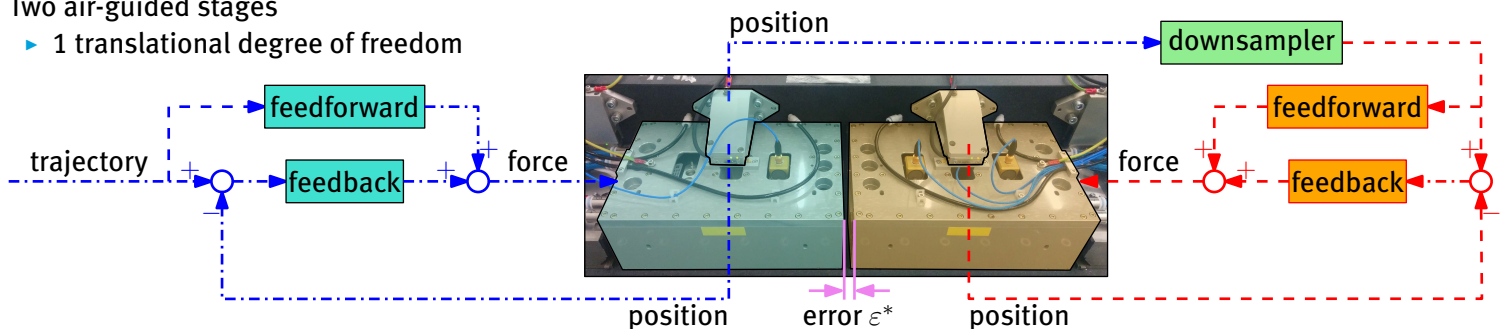
- High position accuracy over a large range
- ▶ example: long stroke – short stroke in wafer stages
 - ▶ different performance requirements for different control loops (e.g., μm vs nm)
 - ▶ performance requirements determine sampling rate

Multirate approach: high accuracy at low cost

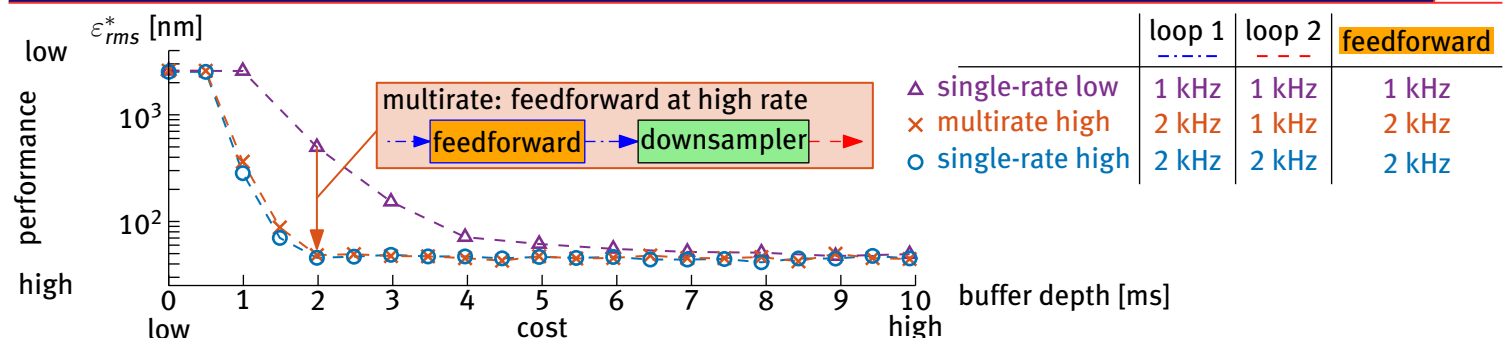
- Different sampling rates in different loops
- ▶ balance performance and hardware cost (sensors, actuators, AD/DA converters)

Experimental dual-stage system

- Two air-guided stages
- ▶ 1 translational degree of freedom



Experimental results: high accuracy at low cost with multirate control



Conclusion

- Multirate control: high performance at low cost
- ▶ Experimental validation multirate control approach
- Related work:
- ▶ Feedback control of LPTV systems [2]
 - ▶ More resource-aware control design [3]

References

- [1] J.C.D. van Zundert, J.L.C. Verhaegh, W.H.T.M. Aangenent, T. Oomen, D. Antunes, and W.P.M.H. Heemels. Feedforward for Multi-Rate Motion Control: Enhanced Performance and Cost-Effectiveness. ACC 2015, pp. 2831-2836.
- [2] Jurgen van Zundert and Tom Oomen. LPTV Loop-Shaping with Application to Non-Equidistantly Sampled Precision Mechatronics. AMC 2018, pp. 467-472.
- [3] Jurgen van Zundert. Resource-Aware Motion Control: Feedforward, Learning and Feedback, PhD thesis, November 2018.